

ONYX® 8" Ultra High Vacuum, IC Target, Standard Magnetics

Metric Specifications

C	onstruction	•	
	Anode		304 Stainless Steel
	Cathode Body		OFHC Copper
	Insulator		Aluminum Oxide (Al ₂ O ₃)
C	ooling Requireme	ents	
	Flow Rate at Maximum Power		Consult Factory
	Maximum Input Pressure, Open Drain		Consult Factory
	Maximum Input	Temperature	Consult Factory
Di	imensions		
	Α	Consult Factory	⊬——B——————————————————————————————————
	В	Consult Factory	
	С	Consult Factory	

General

Magnetic Enhancement	Permanent (NdFeB) Encapsulated
Maximum Temperature, Magnets Demounted	Consult Factory
Maximum Temperature, Magnets Mounted	Consult Factory
Source to Substrate Distance	Consult Factory
Weight, Approximate Without Options	Consult Factory

Maximum Sputtering Power *

Cathode Voltage	Consult Factory
Discharge Current	Consult Factory
Indirect Cooled Mode, DC	Consult Factory
Indirect Cooled Mode, RF	Consult Factory
Operating Pressure	Consult Factory

Mounting, Standard

CF Flange	Consult Factory
Power Connector, DC	Consult Factory
Power Connector, RF	Consult Factory
Water, Outer Dimension Tubing	Consult Factory

Target

Cooling	Indirect
Diameter	Consult Factory
Form	Circular / Planar
Thickness	Consult Factory

Specifications Disclaimer

- All Angstrom Sciences NdFeB magnets are totally encapsulated and protected from degradation by water.
- All sources are available in external configurations.
- * Maximum power for cathode only, a target material's properties, such as, thermal and electrical conductivity may limit the maximum process power level.
- Some custom-engineered and specialty magnetrons may not meet standard specifications.
- Specifications are subject to change without notice.
- Typical performance. Results may vary with process parameters such as pressure, flow rate, target material, and substrate rotation, etc.

Please contact us for specifications regarding your application.

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